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Bib Data Sheet

CONFIRMATION NO. 5722

SERIAL NUMBER 10/678,168	FILING DATE 10/06/2003 RULE	CLASS 257	GROUP ART UNIT 2814	ATTORNEY DOCKET NO. 0756-7208
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APPLICANTS

Shunpei Yamazaki, Setagaya, JAPAN;

Hisashi Ohtani, Tochigi, JAPAN;

Tamae Takano, Atsugi, JAPAN;

**** CONTINUING DATA *******

This application is a DIV of 09/352,194 07/13/1999

**** FOREIGN APPLICATIONS *******

JAPAN 10-203205 07/17/1998

JAPAN 11-135054 05/14/1999

IF REQUIRED, FOREIGN FILING LICENSE GRANTED**** 01/02/2004**

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 13	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 4
Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Examiner's Signature <u>[Signature]</u> Initials <u>[Initials]</u>					

ADDRESS

31780
 ERIC ROBINSON
 PMB 955
 21010 SOUTHBANK ST.
 POTOMAC FALLS , VA
 20165

TITLE

Crystalline semiconductor thin film, method of fabricating the same, semiconductor device, and method of fabricating the same

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
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